S PATENT APPLICATION

Y THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Attorney Docket No.: 2437.09US04

HIATT et al.

Confirmation No.: 2768

Application No.:

10/077,180

Filed: February 15, 2002

For:

ULTRA-MINIATURE MAGNETIC DEVICE

Group Art Unit: 3729

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. § 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This information is being filed before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

José W. Jimenez

Registration No. 31,113

Customer No. 24113

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Please grant any extension of time necessary for entry; charge any fee due to Deposit Account No. 16-0631.

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José W. Jymenez

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FORM PTO-149 MODIFIED

Docket No.: 2437.09US04 Application No.: 10/077,180

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

APPLICANT: HIATT et al.
FILING DATE: February 15, 2002

GROUP ART UNIT: 3729

	4	U.S	. PATENT DOCU	MENTS		
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EXAMINER SIGNATURE

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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.



FORM PTO-1449 MODIFIED

Docket No.: 2437.09US04 Application No.: 10/077,180

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

APPLICANT: HIATT et al.

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GROUP ART UNIT: 3729

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